



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ATTY.'S DOCKET: NREL/96-48

#5/a
H. J. J. J.
1-13-99

Applicant: Timothy A. Gessert)
Serial No.: 08/937,721) Group Art: 1741
Filing Date: September 25, 1997) Examiner: S. Mulburi
Title: ION-BEAM TREATMENT TO)
PREPARE SURFACES OF)
P-CdTe FILMS)

AMENDMENT UNDER 37 CFR §1.115

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

In reply to the Official Action of October 15, 1998,
rejecting the claims in the above-identified patent application,
applicant respectfully request reconsideration, based upon the
amendments hereinafter set forth.

IN THE CLAIMS

Please cancel claim 3 without prejudice.

RECEIVED
DEC 24 1998
GROUP 1700

1. (Amended) A [method] dry process [of] for making a low-

Sub
E

1